Patent Docket No. <u>1232-4609US1</u>



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl	·	/ \
Ann	icani	
χ χ χ χ χ χ χ	LUali	(0).

Kazuaki OHMI et al.

Serial No.:

To be assigned

Group Art Unit:

To be assigned

Filed:

June 25, 2003

Examiner:

To be assigned

For:

SEPARATING APPARATUS, SEPARATING METHOD, AND METHOD OF

MANUFACTURING SEMICONDUCTOR SUBSTRATE

INFORMATION DISCLOSURE STATEMENT

Pursuant to Rule 56, applicant hereby calls the attention of the Patent Office to the references

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 Sir.

listed o	n the attached Form PTO 1449. Copy(ies) of these references are attached were filed in
related	application U.S. Serial No(s), filed, respectively.
	This document is being filed within three (3) months of the filing date of the application
	Please charge the \$180 fee to Deposit Account No. <u>13-4503</u> , Order No This document is being concurrently filed with the above-identified application
	This document is being concurrently filed with an Request for Continued Examination (RCE)
	This document is being filed prior to a first Office Action
	This document is accompanied by a Search Report/Communication cited in a corresponding PCT or foreign counterpart application.
X	The Commissioner is hereby authorized to charge any additional fees which may be required for this Information Disclosure Statement, or credit any overpayment to Deposit Account No. 13-4503, Order No. 1232-4609US1. A DUPLICATE COPY OF THIS SHEET IS ATTACHED.

Respectfully submitted,

MORGAN & FINNEGAN, L.L.P.

Dated: June 25, 2005

By:

James Hwa

Registration No. 42,680

Correspondence Address:

MORGAN & FINNEGAN, L.L.P.

345 Park Avenue

New York, NY 10154-0053

(202) 857-7887 Telephone

(202) 857-7929 Facsimile

Page 1 of 1 Attorney Docket: Serial No.: **FORM PTO-1449** 1232-4609US1 To Be Assigned Applicants: €... INFORMATION DISCLOSURE CITATION Kazuaki OHMI, et al. Filing Date: Group Art Unit: June 25, 2003 To Be Assigned U.S. PATENT DOCUMENTS Examiner Document Date Name Class Sub-Filing Date Initial Number Class 1 6,102,529 08/15/00 Okazaki et al. 347 65 2 06/20/00 344 6,077,383 Laporte 156 3 5,783,022 07/21/98 Cha et al. 156 344 11/15/94 Banholzer et al. 29 890.142 4 5,363,556 5 4,466,852 08/21/84 Beltz et al. 156 344 6 3,969,813 07/20/76 Minetti et al. 29 575 FOREIGN PATENT DOCUMENTS Document Sub-Number Date Country Clas Class Translation Yes No JP 11-45840 02/16/99 Japan (w/ English Abstract) ☐ Yes 🛛 No 8 JP 7-302889 11/14/95 Japan (w/ English Abstract) ☐ Yes 🛛 9 JP 5-21338 01/29/93 Japan (w/ English Abstract) Yes 🗌 No 10 EP 0 867 917 A2 09/30/98 European ☐ Yes 🛛 No ☐ Yes ⊠ No ☐ Yes 🛛 No Yes No OTHER DOCUMENTS (Including Author, Title, Date, etc.) "History of Water Jet Machining Development", Journal of Water Jet Technology, Society of Japan, 11 Vol. 1, 1/1/84 Date Considered Examiner EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP §609. Draw line through citation if not in conformance and not considered.

Include copy of this form with next communication to Applicant.